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#GP/3823
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: AZAM, MIZBAHUL, et al.
Serial No.: 09/705,274
Filing Date: November 3, 2000
Group Art Unit: 2814
Examiner: Unknown
Title: TRENCH GROWTH TECHNIQUES USING
SELECTIVE EPITAXY

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SEMICONDUCTOR COMPONENTS INDUSTRIES, LLC

Name of Assignee

Julie Hall
SIGNATURE

May 25, 2001
DATE

SUBMITTAL OF FORMAL DRAWINGS

Honorable Commissioner of Patents and Trademarks,
Washington, D.C. 20231
Attn: **Official Draftsperson**

SIR:

We are hereby submitting three (3) sheets of formal
drawings for the above-identified patent application.

Respectfully submitted,

Michael T. Wallace

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